

OIP  
INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

NEC NE03P181

Application Number

10/748,821

Applicant(s)

OHTO et al.

Filing Date

December 30, 2003

Group Art Unit

2812

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JS		6,162,743	12.19.00	CHU et al.	438	781	

## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JS		2001/0004550	6.21.01	PASSEMARD	438	618	

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

DATE CONSIDERED

3/1/06

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

*(Use several sheets if necessary)*

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[illegible]

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	2001-127159	11.05.2001	JAPAN (w/Abstract)	H01L	21/768		✓
	2002-083870	22.03.2002	JAPAN (w/Abstract)	H01L	21/768		✓
	2002-275631	25.09.2002	JAPAN (w/Abstract)	C23C	16/42		✓
	WO 99/41423	19.08.1999	WIPO	C23C	A2		✓
	WO 00/19498	06.04.2000	WIPO	H01L	21/027		✓

**EXAMINER**

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